



PATENT APPLICATION
Docket No. 9898-320
Client No. SS-16412-US-DIV

In re application of: Yun-Hyeok Im and Young-Hoon Ro
Serial No.: 10/646,444 Art Unit: 2811
Filed: August 21, 2003 Examiner: not yet assigned
For: SEMICONDUCTOR PACKAGE HAVING DAM AND METHOD
FOR FABRICATING THE SAME
Confirmation No. 9520

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

FOREIGN PATENT DOCUMENTS

Exam Init	Ref	Document Number	Publication Date	Country	Name
VAM I		1994-023007	12/1/1998	Korea	
VAM J		1997-039212	8/18/1997	Korea	

OTHER DOCUMENTS

Exam Init	Ref	Author, Title, Date, Pertinent Pages, Etc.)
VAM J		English language of Korean Patent Publication No. 1994-023007.
VAM J		English language of Korean Patent Publication No. 1997-039212.

Examiner: Vicki A Mcendola g

Date Considered: 3-1-05

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